



INFORMATION DISCLOSURE STATEMENT

Applicant : Lin, et al.
 App. No : 10/815,905
 Filed : March 31, 2004
 For : INTERFEROMETRIC MODULATION
 PIXELS AND MANUFACTURING
 METHOD THEREOF
 Examiner : Unassigned
 Art Unit : 2871

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 547 references to be considered by the Examiner. Also enclosed are 128 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 9/6/06

By: Joseph J. Mallon
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 Registration No. 39,287
 Attorney of Record
 Customer No. 59,747
 (619) 235-8550

INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application No.	10/815,905
		Filing Date	March 31, 2004
		First Named Inventor	Lin, et al.
		Art Unit	2871
(Multiple sheets used when necessary)		Examiner	Unassigned
SEP 08 2006	SHEET 1 OF 22	Attorney Docket No.	QCO.094A/061113

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number <i>Number - Kind Code (if known)</i> Example: 1,234,567 B1.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	2,534,846	12/19/50	Ambrose et al.	
	2	3,439,973	04/22/69	Paul et al.	
	3	3,443,854	05/13/69	Weiss	
	4	3,616,312	10-26-1971	McGriff, et al.	
	5	3,653,741	04/04/72	Marks	
	6	3,656,836	04/18/72	de Cremoux et al.	
	7	3,725,868	04/03/73	Malmer, Jr. et al.	
	8	3,813,265	05/28/74	Marks	
	9	3,955,880	05/11/76	Lierke	
	10	4,099,854	07/11/78	Decker et al.	
	11	4,196,396	04/01/80	Smith	
	12	4,228,437	10/14/80	Shelton	
	13	4,377,324	03/22/83	Durand et al.	
	14	4,389,096	06/21/83	Hori et al.	
	15	4,392,711	07-12-1983	Moraw, et al.	
	16	4,403,248	09/06/83	te Velde	
	17	4,441,791	04/10/84	Hornbeck	
	18	4,445,050	04/24/84	Marks	
	19	4,459,182	07/10/84	te Velde	
	20	4,482,213	11/13/84	Piliavin et al.	
	21	4,500,171	02/19/85	Penz et al.	
	22	4,519,676	05/28/85	te Velde	
	23	4,531,126	07/23/85	Sadones	
	24	4,566,935	01/28/86	Hornbeck	
	25	4,571,603	02/18/86	Hornbeck et al.	
	26	4,596,992	06/24/86	Hornbeck	
	27	4,615,595	10/07/86	Hornbeck	
	28	4,617,608	10-14-1986	Blonder, et al.	

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	29	4,662,746	05/05/87	Hornbeck	
	30	4,663,083	05/05/87	Marks	
	31	4,681,403	07/21/87	te Velde et al.	
	32	4,710,732	12/01/87	Hornbeck	
	33	4,748,366	05/31/88	Taylor	
	34	4,786,128	11/22/88	Birnbach	
	35	4,790,635	12/13/88	Apsley	
	36	4,856,863	08/15/89	Sampsell et al.	
	37	4,859,060	08-22-1989	Kitagirinet al	
	38	4,900,136	02/13/1990	Goldburt et al.	
	39	4,900,395	02/13/1990	Syverson et al.	
	40	4,937,496	06/26/90	Neiger et al.	
	41	4,954,789	09/04/90	Sampsell	
	42	4,956,619	09/11/90	Hornbeck	
	43	4,965,562	10/23/1990	Verhulst	
	44	4,982,184	01/01/91	Kirkwood	
	45	5,018,256	05/28/91	Hornbeck	
	46	5,022,745	06/11/91	Zahowski et al.	
	47	5,028,939	07/02/91	Hornbeck et al.	
	48	5,037,173	08/06/91	Sampsell et al.	
	49	5,044,736	09/03/91	Jaskie et al.	
	50	5,061,049	10/29/91	Hornbeck	
	51	5,075,796	12/24/91	Schildkraut et al.	
	52	5,078,479	01/07/92	Vuilleumier	
	53	5,079,544	01/07/92	DeMond et al.	
	54	5,083,857	01/28/92	Hornbeck	
	55	5,096,279	03/17/92	Hornbeck et al.	
	56	5,099,353	03/24/92	Hornbeck	

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	57	5,124,834	06/23/92	Cusano et al.	
	58	5,136,669	08/04/92	Gerdt	
	59	5,142,405	08/25/92	Hornbeck	
	60	5,142,414	08/25/92	Koehler	
	61	5,153,771	10/06/92	Link et al.	
	62	5,162,787	11/10/92	Thompson et al.	
	63	5,168,406	12/01/92	Nelson	
	64	5,170,156	12/08/92	DeMond et al.	
	65	5,172,262	12/15/92	Hornbeck	
	66	5,179,274	01/12/93	Sampsell	
	67	5,192,395	03/09/93	Boysel et al.	
	68	5,192,946	03/09/93	Thompson et al.	
	69	5,206,629	04/27/93	DeMond et al.	
	70	5,212,582	05/18/1993	Nelson	
	71	5,214,419	05/25/93	DeMond et al.	
	72	5,214,420	05/25/93	Thompson et al.	
	73	5,216,537	06/01/93	Hornbeck	
	74	5,226,099	07/06/93	Mignardi et al.	
	75	5,228,013	07/13/93	Bik	
	76	5,231,532	07/27/93	Magel et al.	
	77	5,233,385	08/03/93	Sampsell	
	78	5,233,456	08/03/93	Nelson	
	79	5,233,459	08/03/93	Bozler et al.	
	80	5,254,980	10/19/93	Hendrix et al.	
	81	5,272,473	12/21/93	Thompson et al.	
	82	5,278,652	01/11/94	Urbanus et al.	
	83	5,280,277	01/18/94	Hornbeck	
	84	5,287,096	02/15/94	Thompson et al.	

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	85	5,293,272	03-08-1994	Jannon, et al.	
	86	5,296,950	03/22/94	Lin et al.	
	87	5,299,041	03/29/94	Morin et al.	
	88	5,305,640	04/26/94	Boysel et al.	
	89	5,311,360	05/10/94	Bloom et al.	
	90	5,312,513	05/17/94	Florence et al.	
	91	5,323,002	06/21/94	Sampsell et al.	
	92	5,324,683	06/28/94	Fitch et al.	
	93	5,325,116	06/28/94	Sampsell	
	94	5,326,430	07/05/94	Cronin et al.	
	95	5,327,286	07/05/94	Sampsell et al.	
	96	5,330,617	07/19/1994	Michael Haond	
	97	5,331,454	07/19/94	Hornbeck	
	98	5,339,116	08/16/94	Urbanus et al.	
	99	5,345,328	09/06/94	Fritz et al.	
	100	5,347,377	09/13/1994	Revelli Jr. et al.	
	101	5,355,357	10/25/1994	Yamamori et al.	
	102	5,358,601	10/25/1994	Cathey	
	103	5,365,283	11/15/94	Doherty et al.	
	104	5,381,232	01/10/95	van Wijk	
	105	5,381,253	01/10/95	Sharp et al.	
	106	5,401,983	03/28/95	Jokerst et al.	
	107	5,411,769	05/02/95	Hornbeck	
	108	5,444,566	08/22/95	Gale et al.	
	109	5,446,479	08/29/95	Thompson et al.	
	110	5,448,314	09/05/95	Heimbuch et al.	
	111	5,452,024	09/19/95	Sampsell	
	112	5,454,906	10/03/95	Baker et al.	

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	113	5,457,493	10/10/95	Leddy et al.	
	114	5,457,566	10/10/95	Sampsell et al.	
	115	5,459,602	10/17/95	Sampsell	
	116	5,459,610	10/17/95	Bloom et al.	
	117	5,461,411	10/24/95	Florence et al.	
	118	5,474,865	12/12/1995	Vasudev	
	119	5,489,952	02/06/96	Gove et al.	
	120	5,497,172	03/05/96	Doherty et al.	
	121	5,497,197	03/05/96	Gove et al.	
	122	5,499,037	03/12/1996	Nakagawa et al.	
	123	5,499,062	03/12/96	Urbanus	
	124	5,500,635	03/19/96	Mott	
	125	5,500,761	03/19/96	Goossen et al.	
	126	5,503,952	04/02/96	Suzuki et al.	
	127	5,506,597	04/09/96	Thompson et al.	
	128	5,515,076	05/07/96	Thompson et al.	
	129	5,517,347	05/14/96	Sampsell	
	130	5,523,803	06/04/96	Urbanus et al.	
	131	5,526,051	06/11/96	Gove et al.	
	132	5,526,172	06/11/96	Kanack	
	133	5,526,327	06/11/96	Cordova, Jr.	
	134	5,526,688	06/18/96	Boysel et al.	
	135	5,535,047	07/09/96	Hornbeck	
	136	5,548,301	08/20/96	Kornher et al.	
	137	5,551,293	09/03/96	Boysel et al.	
	138	5,552,924	09/03/96	Tregilgas	
	139	5,552,925	09/03/96	Worley	
	140	5,559,358	09/24/96	Burns et al.	

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SEP 05 2005

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	141	5,563,398	10/08/96	Sampsell	
	142	5,567,334	10/22/96	Baker et al.	
	143	5,570,135	10/29/96	Gove et al.	
	144	5,579,149	11/26/96	Moret et al.	
	145	5,581,272	12/03/96	Conner et al.	
	146	5,583,688	12/10/96	Hornbeck	
	147	5,589,852	12/31/96	Thompson et al.	
	148	5,597,736	01/28/97	Sampsell	
	149	5,600,383	02/04/97	Hornbeck	
	150	5,602,671	02/11/97	Hornbeck	
	151	5,606,441	02/25/97	Florence et al.	
	152	5,608,468	03/04/97	Gove et al.	
	153	5,610,438	03/11/97	Wallace et al.	
	154	5,610,624	03/11/97	Bhuva	
	155	5,610,625	03/11/97	Sampsell	
	156	5,619,059	04/08/97	Li et al.	
	157	5,619,365	04/08/97	Rhoades et al.	
	158	5,619,366	04/08/97	Rhoades et al.	
	159	5,622,814	04/22/97	Miyata et al.	
	160	5,629,790	05/13/97	Neukermans et al.	
	161	5,633,652	05/27/97	Kanbe et al.	
	162	5,636,052	06/03/97	Arney et al.	
	163	5,636,185	06/03/97	Brewer et al.	
	164	5,638,084	06/10/97	Kalt	
	165	5,638,946	06/17/97	Zavracky	
	166	5,641,391	06/24/97	Hunter et al.	
	167	5,646,768	07/08/97	Kaeiyama	
	168	5,647,819	07/15/1997	Fujita, et al.	

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	169	5,650,834	07/22/1997	Nakagawa et al.	
	170	5,650,881	07/22/97	Hornbeck	
	171	5,654,741	08/05/97	Sampsell et al.	
	172	5,657,099	08/12/97	Doherty et al.	
	173	5,659,374	08/19/97	Gale, Jr. et al.	
	174	5,665,997	09/09/97	Weaver et al.	
	175	5,673,139	09/30/97	Johnson	
	176	5,674,757	10/07/97	Kim	
	177	5,683,591	11/04/97	Offenberg	
	178	5,703,710	12/30/97	Brinkman et al.	
	179	5,706,022	01/06/98	Hato	
	180	5,710,656	01/20/98	Goosen	
	181	5,726,480	03/10/98	Pister	
	182	5,739,945	04/14/98	Tayebati	
	183	5,745,193	04/28/98	Urbanus et al.	
	184	5,745,281	04/28/98	Yi et al.	
	185	5,771,116	06/23/98	Miller et al.	
	186	5,784,190	07/21/98	Worley	
	187	5,784,212	07/21/98	Hornbeck	
	188	5,793,504	08/11/98	Stoll	
	189	5,808,780	09/15/98	McDonald	
	190	5,818,095	10/06/98	Sampsell	
	191	5,822,170	10/13/1998	Cabuz et al.	
	192	5,824,608	10/20/1998	Gotoch, et al.	
	193	5,825,528	10/20/98	Goosen	
	194	5,835,255	11/10/98	Miles	
	195	5,838,484	11/17/1998	Gossen et al.	
	196	5,842,088	11/24/98	Thompson	

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	197	5,867,302	02/02/1999	Fleming et al.	
	198	5,912,758	06/15/99	Knipe et al.	
	199	5,943,158	08/24/99	Ford et al.	
	200	5,959,763	09/28/99	Bozler et al.	
	201	5,972,193	10/26/99	Chou et al.	
	202	5,976,902	11/02/99	Shih	
	203	5,986,796	11/16/99	Miles et al.	
	204	6,016,693	01/25/2000	Viani et al.	
	205	6,028,690	02/22/00	Carter et al.	
	206	6,038,056	03/14/00	Florence et al.	
	207	6,040,937	03/21/00	Miles	
	208	6,049,317	04/11/00	Thompson et al.	
	209	6,055,090	4/25/2000	Miles et al.	
	210	6,057,903	05/02/2000	Colgan et al.	
	211	6,061,075	05/09/00	Nelson et al.	
	212	6,099,132	08/08/00	Kaeriyama	
	213	6,100,872	08/08/00	Aratani et al.	
	214	6,113,239	09/05/00	Sampsell et al.	
	215	6,115,326	09/05/2000	Puma et al.	
	216	6,158,156	12/12/2000	Patrick, David	
	217	6,147,790	11/14/00	Meier et al.	
	218	6,160,833	12/12/00	Floyd et al.	
	219	6,166,422	12/26/2000	Qian et al.	
	220	6,180,428	01/30/01	Peeters et al.	
	221	6,194,323	02/27/2001	Downey et al.	
	222	6,195,196	02/27/01	Kimura et al.	
	223	6,201,633	03/13/01	Peeters et al.	
	224	6,204,080	03/20/2001	Hwang	

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225	6,232,936		05/15/01	Gove et al.	
226	6,243,149		06/05/01	Swanson et al.	
227	6,246,398		06/12/2001	Koo	
228	6,249,039		06/19/2001	Harvey et al.	
229	6,282,010		08/28/01	Sulzbach et al.	
230	6,284,560		09-04-2001	Jech, et al.	
231	6,295,154		09/25/01	Laor et al.	
232	6,323,982		11/27/01	Hornbeck	
233	6,327,071		12/04/2001	Kimura et al.	
234	6,329,297		12/11/2001	Balish et al.	
235	6,335,831		01/01/2002	Kowarz et al.	
236	6,351,329		02/26/2002	Greywal Dennis Stanley	
237	6,356,254		03/12/02	Kimura, Koichi	
238	6,376,787		04/23/02	Martin, et al.	
239	6,391,675		05/21/2002	Ehmke et al.	
240	6,392,233		05/2002	Channin et al.	
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244	6,452,465		09/17/02	Brown et al.	
245	6,456,420		09/24/02	Goodwin-Johansson	
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247	6,466,354		10/15/02	Gudeman	
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250	6,480,177		11/12/02	Doherty et al.	
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Examiner Signature	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application No.	10/815,905
		Filing Date	March 31, 2004
		First Named Inventor	Lin, et al.
		Art Unit	2871
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U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	253	6,522,801	02/18/2003	Aksyuk et al.	
	254	6,531,945	03/11/2003	Ahn et al.	
	255	6,545,335	04/08/03	Chua et al.	
	256	6,548,908	04/15/03	Chua et al.	
	257	6,549,338	04/15/03	Wolverton et al.	
	258	6,552,840	04/22/03	Knipe	
	259	6,574,033	06/03/03	Chen et al.	
	260	6,577,785	06-10-2003	Spahn et al	
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	262	6,600,201	07/29/03	Hartwell et al.	
	263	6,606,175	08/12/03	Sampsell et al.	
	264	6,608,268	08/19/03	Goldsmith	
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	266	6,625,047	09/23/03	Coleman, Jr., deceased	
	267	6,630,786	10/07/03	Cummings et al.	
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	269	6,635,919	10/21/03	Melendez et al.	
	270	6,642,913	11/04/2003	Kimura et al.	
	271	6,643,069	11/04/03	Dewald	
	272	6,650,455	11/18/03	Miles, Mark W.	
	273	6,657,832	12/02/03	Williams et al.	
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	280	6,720,267	04/13/04	Chen et al.	

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		Filing Date	March 31, 2004
		First Named Inventor	Lin, et al.
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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	281	6,736,987	05-18-2004	CHO	
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	284	6,741,503	05/25/04	Farris et al.	
	285	6,743,570	06/01/04	Harnett et al.	
	286	6,747,785	06/08/04	Chen et al.	
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	288	6,756,317	06/29/04	Sniegowski, et al.	
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	290	6,775,174	08/10/04	Huffman et al.	
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	296	6,819,469	11/16/04	Koba	
	297	6,822,628	11/23/04	Dunphy et al.	
	298	6,829,132	12/07/04	Martin et al.	
	299	6,853,129	02/08/05	Cummings et al.	
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	301	6,859,218	02/22/05	Luman et al.	
	302	6,861,277	03/01/05	Monroe et al.	
	303	6,862,022	03/01/05	Slupe	
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		First Named Inventor	Lin, et al.
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U.S. PATENT DOCUMENTS					
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	309	6,882,461	04/19/05	Tsai et al.	
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	321	20010040649	11/15/01	Ozaki	
	322	2001-0040675	11-15-2001	True, et al.	
	323	2002-0015215	02/07/02	Miles	
	324	2002-0021485	02/21/2002	Pilossof	
	325	2002-0024711	02/28/2002	Miles	
	326	2002-0036304	03/28/2002	Ehmke et al.	
	327	2002-0054424	5/9/2002	Miles	
	328	2002/055253	05/09/02	Rudhard	
	329	2002-0071169	06/13/2002	Bowers et al.	
	330	2002-0075555	06/20/2002	Miles	
	331	2002-0086455	07-04-2002	Franosch et al.	
	332	2002-0126364	09/12/02	Miles	
	333	2002/137072	09/26/02	Mirkin et al.	
	334	2002-0135857	09/26/02	Fitzpatrick et al.	
	335	2002-149828	10/17/2002	Miles	
	336	2002-0168136	11/14/2002	Atia et al.	

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		First Named Inventor	Lin, et al.
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U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number <i>Number - Kind Code (if known)</i> Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	337	2003-0006468	01/09/2003	Ma et al.	
	338	2003-0043157	03/06/2003	Miles	
	339	2003-0054588	03/20/2003	Patel, et al.	
	340	2003-0062186	04/03/2003	Boroson et al.	
	341	2003-0072070	04/17/2003	Miles	
	342	2003-0090350	05/15/2003	Feng et al.	
	343	2003-0112096	06/19/2003	Potter	
	344	2003-0138213	07/24/2003	Jiin et al.	
	345	2003-0152872	08/14/2003	Miles, Mark W.	
	346	2003-0201784	10/30/2003	Potter	
	347	2003-0202264	10/30/2003	Weber et al.	
	348	2003-0202265	10/30/2003	Reboa et al.	
	349	2003-0202266	10/30/2003	Ring et al.	
	350	2003-0231373	12-18-2003	Kowarz	
	351	2004-0010115	01-15-2004	Sotzing	
	352	2004-0028849	02-12-2004	Stark et al.	
	353	2004-0027636	02-12-2004	Miles	
	354	2004-0027701	02-12-2004	Ishikawa	
	355	2004-0035821	02-26-2004	Doan et al.	
	356	2004-0051929	03-18-2004	Sampsell et al.	
	357	2004-0053434	03-18-2004	Bruner	
	358	2004-0058532	03-25-2004	Miles et al.	
	359	2004-0058531	03-25-2004	Miles et al.	
	360	2004-0061543	04-01-2004	Nam et al.	
	361	2004-0063322	04-01-2004	Yang	
	362	2004-0080807	04-29-2004	Chen et al.	
	363	2004-0080832	04-29-2004	Singh	
	364	2005-0087086	05-06-2004	Lee	

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		First Named Inventor	Lin, et al.
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U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number <i>Number - Kind Code (if known)</i> Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
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	368	2004-0125282	07-01-2004	Lin, et al.	
	369	2004-0125536	07-01-2004	Arney et al.	
	370	2004-0136076	07-15-2004	Tayebati Parviz	
	371	2004-0148009	07-29-2004	Buzzard	
	372	20040145049	07-29-2004	McKinnell et al.	
	373	20040147056	07-29-2004	McKinnell et al.	
	374	2004-0145811	07-29-2004	Lin, et al.	
	375	2004-0147198	07-29-2004	Lin, et al.	
	376	2004-0150869	08-05-2004	Kasai, Hiroto	
	377	2004-0160143	08-19-2004	Shreeve et al.	
	378	20040174583	09/09/04	Chen et al.	
	379	2004/0175577	09/09/04	Lin et al.	
	380	2004-0179445	09/16/2004	Park	
	381	20040179281	09/16/04	Reboa	
	382	2004/0191937	09/30/04	Patel et al.	
	383	2004/0207897	10/21/04	Lin	
	384	2004/0209192	10/21/04	Lin et al.	
	385	2004/0209195	10/21/04	Lin	
	386	20040212026	10/28/04	Van Brocklin et al.	
	387	20040217378	11/04/04	Martin et al.	
	388	20040217919	11/04/04	Pichl et al.	
	389	20040218251	11/04/04	Piehl et al.	
	390	20040218334	11/04/04	Martin et al.	
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U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	393	2004/0240027	12/02/04	Lin et al.	
	394	20040240032	12/02/04	Miles	
	395	20040240138	12/02/04	Martin et al.	
	396	20040245588	12/09/04	Nikkel et al.	
	397	20040263944	12/30/04	Miles et al.	
	398	20050001828	01/06/05	Martin et al.	
	399	2005/0003667	01/06/05	Lin et al.	
	400	2005/0020089	01/27/05	Shi et al.	
	401	2005/0024557	02/03/05	Lin	
	402	2005/0035699	02/17/05	Tsai	
	403	2005/0036095	02/17/05	Yeh et al.	
	404	2005/0036192	02/17/05	Lin et al.	
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	406	2005/0042117	02/24/05	Lin	
	407	2005/0046922	03/03/05	Lin et al.	
	408	2005/0046948	03/03/05	Lin	
	409	20050057442	03/17/05	Way	
	410	20050068583	03/31/05	Gutkowski et al.	
	411	20050069209	03/31/05	Damera-Venkata et al.	
	412	2005/0068605	03/31/05	Tsai	
	413	2005/0068606	03/31/05	Tsai	
	414	2005/0078348	04/14/05	Lin	
	415	2005/0168849	08/04/05	Lin	
	416	2005/0195462	09/08/05	Lin	
	417	2005-0195467	09/08/2005	Kothari et al.	
	418	2005/0202649	09/15/05	Hung et al.	
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Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	420	CH 681 047	12-31-1992	Landis & GYR Betriebs		
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	426	EP 1197778A	04/17/2002	Aksyuk et al.		
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	429	EP 0 667 548 A1	08-16-1995	AT&T Corporation		
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	431	JP 10-148644	06/02/1998	TDK Corp		
	432	JP 10-267658	10/09/1998	Nissan Motor Corp.		
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	435	JP 11243214	09/07/1999	Nippon Telegr & Teleph	Abstract Only	
	436	JP 2000-40831A	02/08/2000	Denso Corp	Abstract Only	
	437	JP 2002-270575	09/02/2002	Seiko Epson Corp.		
	438	JP 2002-355800	12/10/2002	Samsung Electronics	Abstract Only	
	439	JP 2004-102022A	04/02/2004	Ricoh Co. Ltd.	Abstract Only	
	440	JP 2004-212656	07/29/2004	Fuji Photo Film	Abstract Only	
	441	JP 05275401 A1	10-22-1993	Yokogawa Electric Corp.		
	442	JP 2002 062493	2/28/2002	Canon Inc.		
	443	JP 2004106074 A	4/8/2004	Sony Corp		
	444	JP 2003-001598	01-08-2003	Sony Corp		
	445	JP 2005-051007	02-24-2005	Tokyo Electric		
	446	KR 2000-0033006	06/15/2000	Moon et al.		
	447	KR 2002-9270	10/23/1999			
	448	RCO Pt Pub 157313	05/01/1991	FSI International		
	449	WO 01/14248	03/01/2001	Knowles Electronics		

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		Filing Date	March 31, 2004
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FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	450	WO 03/052506	06/26/2003	Nokia Corporation		
	451	WO 05/085932A	09/15/2005	Kothari et al.		
	452	WO 06/036385	04/06/2006	IDC, LLC		
	453	WO 06/036437	04/06/2006	IDC, LLC		
	454	WO06/036542	04/06/2002	IDC, LLC		
	455	WO 92/10925	06/25/1992	Robert Bosch GmbH		
	456	WO 02/24570	03-28-2002	Marconi Caswell Ltd.		
	457	WO 03/069413 A	8/21/2003	Iridigm Display Corp.		
	458	WO 2005/019899 A1	3/3/2005	Iridigm Display Corp.		
	459	WO 03/007049A1	01-23-2003	Iridigm Display Corp.		
	460	WO03073151A1	09-04-2003	Iridigm Display Corp.		
	461	WO04006003A1	01-15-2004	Iridigm Display Corp.		
	462	WO04026757A2	04-01-2004	Iridigm Display Corp.		
	463	WO9530924	11-16-1995	Etalon, Inc.		
	464	WO9717628	05-15-1997	Etalon, Inc.		
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
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NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	472	Austrian Search Report for EX81/2005 dated May 18, 2005.	
	473	Austrian Search Report for EX170/2005 dated July 6, 2005.	
	474	Austrian Search Report for EX139/2005 dated July 27, 2005.	
	475	Austrian Search Report for EX144/2005 dated August 11, 2005.	
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	480	CONNER, "Hybrid Color Display Using Optical Interference Filter Array," SID Digest, pp. 577-580 (1993).	
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